A D-type dual side-polished, highly sensitive, plasma refractive index sensor based on photonic crystal fiber

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In this paper, a D-shape dual side-polished (DSP) photonic crystal fiber (PCF) sensor based on high sensitivity and high range refractive index (RI) is proposed and analyzed. The surface of the structure is plated with Au and TiO_2, which can enhance the surface plasmon resonance (SPR) effect and sensitivity. The characteristics of the sensor were analyzed by finite element method (FEM). Its RI scope of detection is 1.38−1.42, and by optimizing geometric parameters, the optimal wavelength sensitivity (WS) is 22,100 nm/RIU. Additionally, the WS for DSP-PCF is far better than the recently reported PCF sensors in the above mentioned RI detection range to the best of our knowledge. With these significant outcomes over the analyte RI range, which is helpful for the fields of environmental detection and medical diagnosis.

KEYWORDS

surface plasmon resonance, photonic crystal fiber, wavelength sensitivity, refractive index, TiO2

Introduction

In recent years, photonic crystal fiber (PCF) have been widely used in medical diagnosis [1–4], temperature sensing [5, 6], environmental detection and other fields [7]. Various PCF structures have been discovered, such as D-shape structures [8], hexagonal inner metal coatings [9], multi-channel sensing structures [10], and outer metal coatings [11]. These structures can be roughly divided into two categories. In internal sensing, the pores of the PCF are selectively filled with analytes, while in external sensing the analytes are deposited on the surface of the sensor. So the feasibility of external sensing is higher. According to recent reports, the analyte medium and gold nano-ribbons are placed on the fiber surface, acting as external sensors, creating bidirectional channels, increasing sensitivity, and reducing surface coating area [12].

It has been reported that the selection of suitable PCF materials results in significantly enhanced coupling strength and sensitivity of the sensor. The most common plasma metals are gold and silver, respectively. Silver has sharper resonance peaks but is not

TABLE 1 Performance comparison of the proposed sensor with other recent reported PCF sensors.

Ref	year	Structure	RI range	Max sensitivity (nm/RIU)
[38]	2015	Ring based hexagonal PCF sensor	1.33–1.37	4,000
[39]	2016	Rectangular lattice and dual-core	1.33–1.41	14,216
[31]	2018	D-shaped and two micro-openings	1.31–1.37	11,750
[40]	2020	Ag–TiO$_2$ PCF-SPR	1.33–1.36	10,600
[41]	2020	Ag-ZnO coated D-PCF	1.37–1.40	6,000
[42]	2021	Side-polished PCF	1.35–1.39	12,500
This work	—	D-shape double-sided polished PCF-SPR sensor	1.38–1.42	22,100

chemically stable. Gold has a more pronounced resonance peak shift than silver. Gold is also less sensitive to temperature and humid issues than silver [13]. So, most of the PCF-SPR sensors have been conducted with gold as plasmonic metal. Moutusi De et al. proposed an efficient, birefringent D-shape PCF-SPR sensor using gold as the plasmonic metal with WS of 9,245 nm/RIU [14]. Depositing a layer of modifier material on the metal film can enhance the performance of the SPR sensor, TiO$_2$ has higher corrosion resistance and it can enable better interaction of surface plasmon with the attached metal layer [15, 16]. Emranul Haque et al. deposited TiO$_2$ on a metal film. They proposed a high-sensitivity SPR sensor based on a dual-core PCF with a maximum wavelength sensitivity (WS) of 10,600 nm/RIU [17]. The wavelength sensitivity is defined as a shift in resonance wavelength with respective to refractive index variation and follows the expression (d$_L$/d$_n$). In addition, by optimizing the size and arrangement of air holes in the PCF, the evanescent field strength can be increased to further enhance the property of the sensor. Haque E et al. [18] proposed a PCF based on D-shape square lattice pores, and the sensor has a WS of 20,000 nm/RIU. Jianfei Liao et al. [19] proposed a high-sensitivity near-infrared birefringent PCF sensor, which is a hexagonal internal sensing structure with an average sensitivity of 8,083 nm/RIU.

So far, our group has studied single-mode fibers based on cylindrical tapered [20] and cylindrical multi-mode fibers based on Au/ZnO/WS$_2$ [21]. In this paper, high-sensitivity D-type double-sided polished PCF-SPR sensor is proposed. Compared with single-mode fiber and multi-mode fiber, PCF has lower optical loss, higher optical non-linearity and can be modified by micro-structure design. Gold is selected as the plasmonic material for the sensor, and TiO$_2$ is deposited on the gold layer. TiO$_2$ can improve the coupling result between the core mode and the surface plasmon polarization (SPP) mode [22], thereby further enhancing the resonance of the sensor. By optimizing the structural parameters of the sensor, the maximum WS of the sensor is 22,100 nm/RIU. Considering the manufacturing error and feasibility, the sensor is optimized while analyzing the influence of changes in various parameters.

Geometry structure and theoretical modeling

Figure 1 is a 2D cross-sectional view of the proposed D-shape dual side-polished (DSP) PCF-SPR sensor with high sensitivity. It consists of 12 air holes, of which the inner air holes are arranged in a regular hexagonal structure, and the distance between adjacent air holes in the PCF is Λ. The diameter of the 6 small air holes in the inner layer is d$_1$, and the diameter of the 6 air holes in the outer layer is d$_2$. Both sides of the D-shape PCF are ground and polished surfaces, and the ground and polished surfaces are coated with gold nano-films and TiO$_2$ films. In order to improve the calculation accuracy, a perfectly matched layer (PML) is added to the outer wall of the fiber. The substrate material of the sensor is SiO$_2$, and the refractive index (RI) of SiO$_2$ can be calculated by the Sellmeier equation [23]:
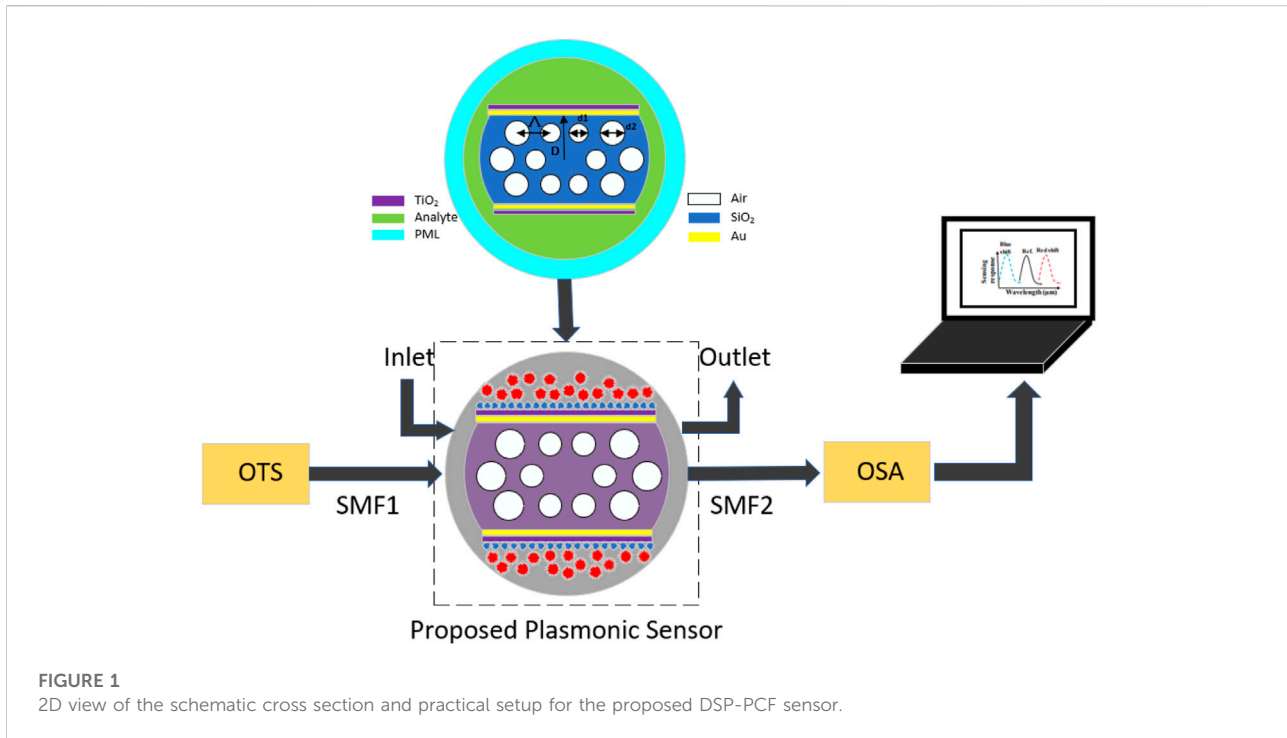
$$n_{SiO2}^2(\lambda) = 1 + \frac{0.6961663\lambda^2}{\lambda^2 - 0.0046791} + \frac{0.4079426\lambda^2}{\lambda^2 - 0.0135120} + \frac{0.8974794\lambda^2}{\lambda^2 - 97.9340025} \quad (1)$$

where λ represents the wavelength of the incident light in microns. The dielectric constant of gold is derived from the Drude model [24]:

$$\varepsilon_{Au} = \varepsilon_\infty - \frac{\omega_D^2}{\omega(\omega + j\gamma_D)} - \frac{\Delta\varepsilon\Omega_L^2}{(\omega^2 - \Omega_L^2) + j\Gamma_L\omega} \quad (2)$$

Where ε_∞ represents the dielectric constant value at high frequency is 5.9673, ω is the angular frequency, Υ_D is the damping frequency, $\Upsilon_D/2\pi$ = 15.92 THz, ω_D is the plasmon frequency, $\omega_D/2\pi$ = 2,113.6 THz, Ω_L = 650.07 THz, $\Gamma_L/2\pi$ = 104.86 THz. TiO$_2$ is the adhesive layers that has been used in this paper. It helps gold to have a strong attachment with silica as well as to boost up the sensing performance. The RI of TiO$_2$ is derived from the following equation [25]:

$$n_{Ti} = \sqrt{5.913 + \frac{2.441 \times 10^7}{(\lambda^2 - 0.803 \times 10^7)}} \quad (3)$$

FIGURE 1
2D view of the schematic cross section and practical setup for the proposed DSP-PCF sensor.

The whole simulation has been employed in Comsol Multiphysics v5.5. The total sensor radius is kept at 6.7 µm with a non-physical PML employed at the outermost layer of the fiber having a thickness of 0.9 µm, which is around 13% of the total radius. PML acts like a boundary condition that absorbs surface radiations. The physical and optical properties of PML should be the same as the background material of the fiber to avoid noteworthy changes in sensing performance. However, fabricating the lattice design is manageable by utilizing the existing technologies. The sensor provides circular air holes of different sizes and is coated with gold and titanium dioxide. The Stack-and-draw technique potentially fabricates annular air holes [26]. Reference [27] established a fiber side-polishing system to achieve PCF polishing. In this polished system, the abrasive wheel can move back and forth in the horizontal direction during the polishing process and its lapping films can be easily replaced. Thus, we can control the horizontal moving range of the abrasive wheel to determine the side-polished length of the PCF. Compared with the fabrication of the D-shaped PCF in a curved V-groove [28], this technology can be used to control the side-polished length h and the SPL of the D-shaped PCF more accurately, which can meet the requirements of different designs. Chemical vapor deposition (CVD), wheel polishing, or high-pressure chemical deposition can be utilized for coating the thin layers of gold, TiO_2 [26].

Although the proposed sensor is theoretically designed, a schematic experimental setup of the sensor's sensing system in practice is shown in Figure 1. The system consists of an optically tunable source (OTS), polarization controller, and optical spectrum analyzer (OSA), connected by a single-mode fiber (SMF). The analyte is located on the outside of the PCF, and the inlet (the analyte) and the outlet (the analyte) are controlled by a pump. When the RI of the analyte changes, a blue or red shift of the loss peak can be observed.

Results and discussion

The sensing characteristics of the PCF were numerically simulated by the FEM software COMSOL Multiplicity with an an-isotropic perfectly matched layer. After optimizing the geometry parameters of PCF, take $d_1 = 1$ µm, $d_2 = 1.4$ µm, $\Lambda = 1.89$ µm, polishing depth D = 3 µm, gold film thickness $t = 20$ nm, TiO_2 thickness g = 10 nm. Figure 2 shows the dispersion correlation between the plasmon and the core mode when the refractive index is 1.39, in which the red curve is the spectral loss diagram of resonance, and the blue and green curves represent the effective refraction of the core mode and the SPP mode, respectively. In a photonic crystal fiber, air holes basically work as the cladding region. When light is transmitted, the whole optical field is confined within the core mode. On the contrary, SPP mode appears at the sensing medium where the plasmonic material has been coated. At the resonance condition, the wave vector of incident light of the core mode and surface plasmonic waves of the SPP mode gets equal with each other, which can also be defined as a phase-
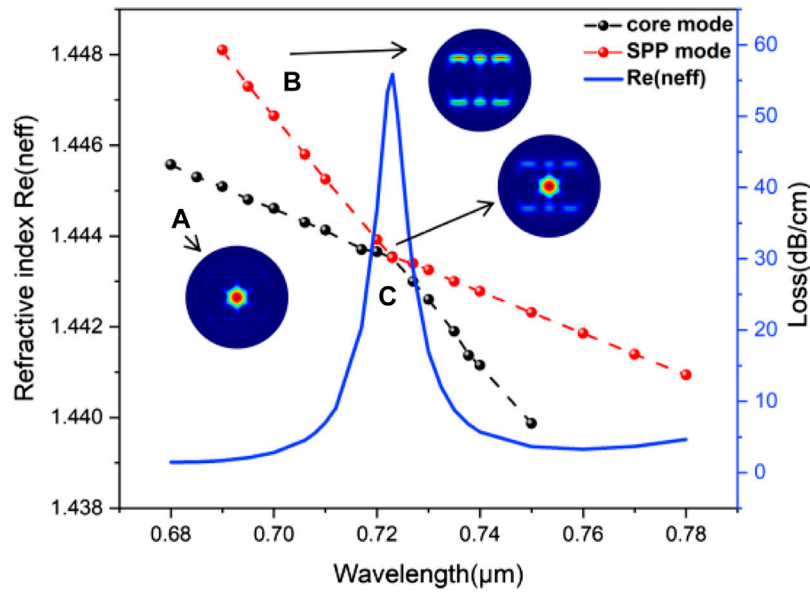
FIGURE 2
Dispersion relation of the core mode and the SPP mode and loss spectrum. Insets **(A–C)**: Energy distribution at each point.

matching condition [29]. Inset 1) shows the core mode of y-polarization, and almost all the energy is confined to the core. Inset 2) shows the SPP mode of y-polarization, and energy is penetrated on the Au-TiO$_2$ and analyte interface.

As resonance condition is satisfied, a loss peak is observed in narrow band that shows the wavelength shifts corresponding to any change in RI of sensing or dielectric medium adjacent to metal layer. In case of PCF SPR sensors, at resonance condition, as real part of effective RI of core mode matches with effective RI of surface plasmon mode, and maximum energy is exchanged from core mode to surface plasmon mode [12].

As can be seen from Figure 2, the real part of the effective refractive index of the core mode and the SPP mode both decrease with the increase of the wavelength, but the real part of the SPP mode decreases faster, and the loss also increases with the increase of the wavelength. The resonance occurs at 0.723 μm where the real part of effective index of the core guided mode and SPP mode cross each other and the imaginary part of the core mode is maximum. At this wavelength, the Re (n_{eff}) of the core mode and the SPP mode are equal, and the matching condition is satisfied, that is, the SPR effect occurs at the intersection of the two curves.

The propagation loss or confinement loss has been calculated by the following equation [30]:

$$\propto = \frac{40 * \pi * Im\left(n_{eff}\right)}{ln\ (10) * \lambda} \approx 8.686 \times k_0 * Im\left(n_{eff}\right) \times 10^4 \quad (4)$$

where, number of waves in free space is specified by, k0 = 2π/λ, operating wavelength is determined by λ and imaginary part of the effective RI is represented by Im (n_{eff}).

We can improve the performance of the sensor by optimizing the parameters of the sensor. The optimization process is to continuously adjust some parameters and keep the rest of the parameters unchanged. So far, many researchers [31–34] have adopted this approach. The parameters that need to be optimized are air hole diameters d$_1$ and d$_2$, gold film thickness t, TiO$_2$ thickness g, adjacent air hole spacing Λ, and polishing depth D.

The thickness of the gold film greatly affects the performance of the sensor. Thin gold layers lead to weak coupling between core and SPP modes, while thicker gold layers lead to over-coupling between core and SPP modes. Figure 3A shows the dependence of the loss spectrum on the change in Au film thickness t from 19 to 21 nm for the analyte RI of 1.41 and 1.42. It can be found that the resonance wavelength gradually red-shifts with the increase of the thickness of the Au film. According to Figure 3A, when the Au film thickness is 19 nm, 20 nm, 21 nm, the resonance loss peak shifts are 144, 167, and 206 nm, respectively. When the thickness is 21 nm, the offset is the largest, but there is no full width at half maximum of the resonance peak at this time. Therefore, the thickness of the Au film was chosen to be 20 nm. According to the relationship between thickness and sensitivity shown in the figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance of Au film needs to be controlled within the upper and lower limits of 5%.
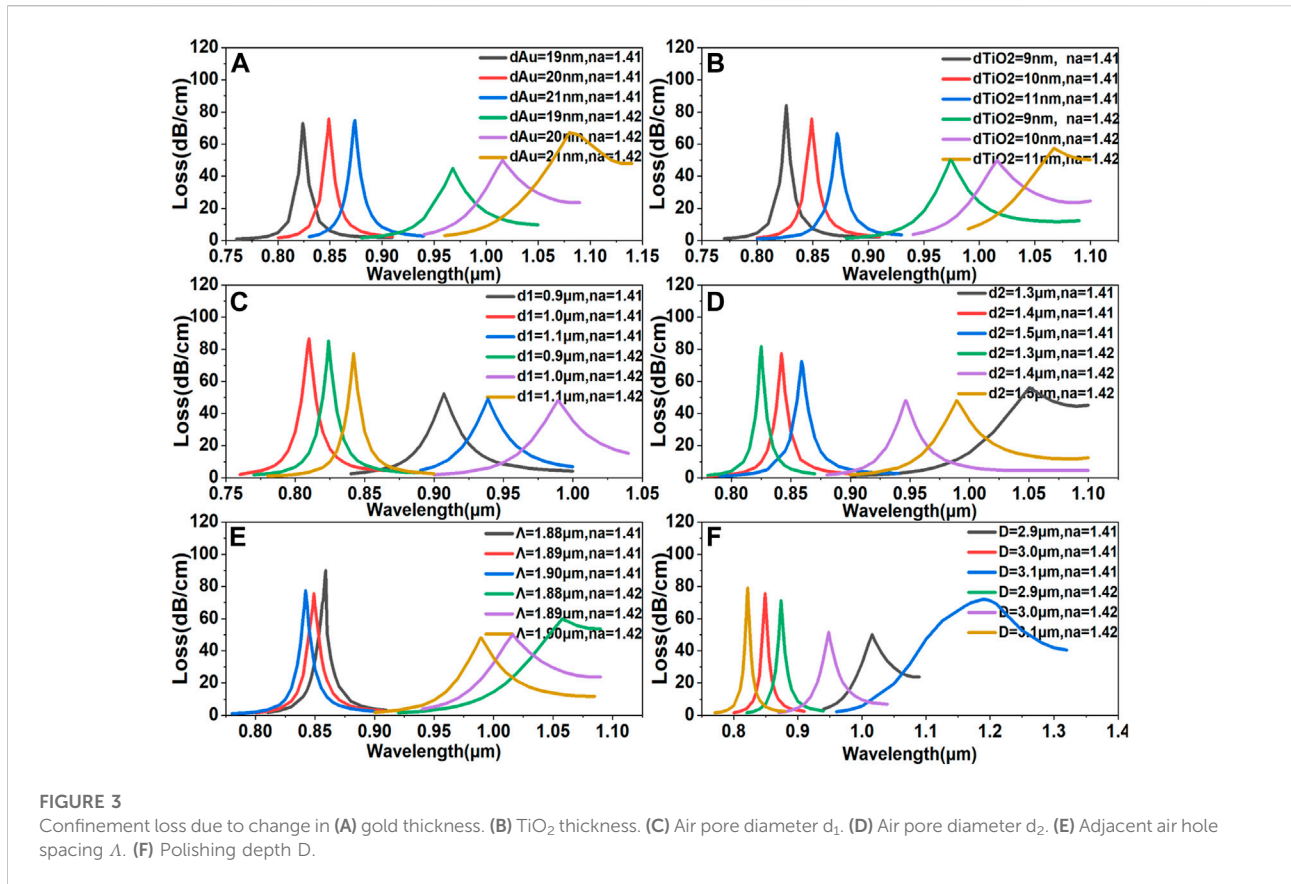
FIGURE 3
Confinement loss due to change in **(A)** gold thickness. **(B)** TiO_2 thickness. **(C)** Air pore diameter d_1. **(D)** Air pore diameter d_2. **(E)** Adjacent air hole spacing Λ. **(F)** Polishing depth D.

Figure 3B shows the correlation of the loss spectrum with the change in TiO_2 thickness g from 9 to 11 nm for analyte RI of 1.41 and 1.42. The TiO_2 layer has an effect on enhancing the evanescent field which can act as a transition metal and help to attract the evanescent field of the core [35], the interaction between the plasmon and the metal evanescent field will be enhanced, and the sensitivity will be increased. According to Figure 3B, the resonance wavelength is gradually red-shifted with the increase of TiO_2 thickness, and the resonance loss peak shifts are 148, 167, and 195 nm when the TiO_2 thickness is 9, 10, and 11 nm, respectively. Although the offset is the largest when the thickness is 11 nm, there is no full width at half maximum of the resonance peak. Therefore, the thickness of the TiO_2 film was chosen to be 10 nm. According to the relationship between thickness and sensitivity shown in the figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance of TiO_2 film needs to be controlled within the upper and lower limits of 10%.

The structural parameters of the sensor are crucial to the performance of the sensor and have a significant impact on the resonant wavelength. Figure 3C shows the dependence of the loss spectrum on the variation of the air hole diameter d1 from 0.9 to 1.1 μm for RI of 1.41 and 1.42. It can be seen from the figure that when d_1 increases from 0.9 to 1.1 μm, the loss drops from 85.28 dB/cm to 66.39 dB/cm, so increasing d_1 will reduce the

loss and the energy can be well confined to the core. Besides, the resonance wavelength gradually red-shifts with the increase of d_1, which indicates that the pore radius can tune the resonance intensity. And when d_1 is 0.9, 1, and 1.1 μm, the resonance loss peak shift amounts are 115, 147, and 208 nm, respectively. Since there is no full width at half maximum when $d_1 = 1.1$ μm, $d_1 = 1$ μm is the best choice for this design considering the offset and waveform. According to the relationship between thickness and sensitivity shown in the figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance needs to be controlled within the upper and lower limits of 10%.

Figure 3D shows the dependence of the loss spectrum on the change in air pore diameter d_2 from 1.3 to 1.5 μm for analyte RI of 1.41 and 1.42. According to Figure 3D, the resonance loss keeps increasing as d_2 increases. This is because as the radius keeps increasing, it gradually squeezes the maximum light energy in the core region and helps the energy to couple with the SPP mode, so the loss will be high [30]. And when d_2 is 1.3, 1.4, and 1.5 μm, the resonance loss peak shift amounts are 192, 147, and 121 nm, respectively. Among them, when d_2 is 1.3 μm, the offset is the largest, but when d_2 is 1.3 μm, the full width at half maximum of the resonance peak does not exist, so the air hole diameter d_2 is selected to be 1.4 μm. According to the relationship between thickness and sensitivity shown in the
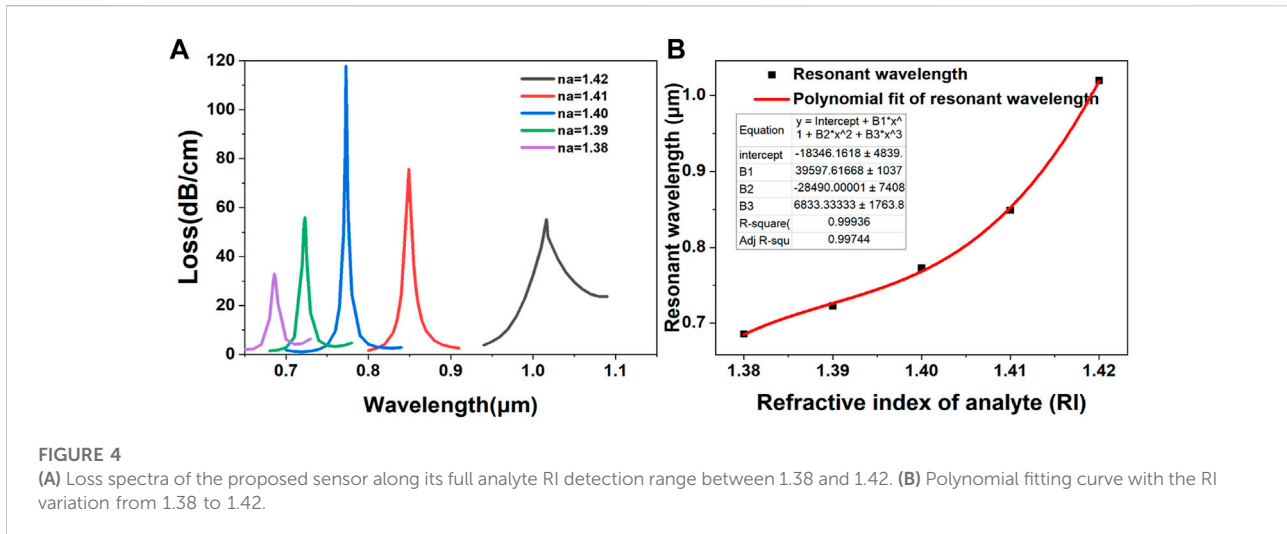
FIGURE 4
(A) Loss spectra of the proposed sensor along its full analyte RI detection range between 1.38 and 1.42. **(B)** Polynomial fitting curve with the RI variation from 1.38 to 1.42.

figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance needs to be controlled within the upper and lower limits of 7%.

Figure 3E shows the dependence of the loss spectrum on the change in adjacent air hole spacing Λ from 1.88 to 1.90 μm for analyte RI of 1.41 and 1.42. It can be seen from the figure that the resonance wavelength is gradually blue-shifted with the increase of the adjacent air hole spacing Λ, because the interaction between the core mode and the SPP mode decreases when Λ increases [36]. And when Λ is 1.88, 1.89, and 1.90 μm, the resonance loss peak shift amounts are 167, 197, and 147 nm, respectively. Among them, when Λ is 1.89 μm, the offset is the largest, that is, when Λ is 1.89 μm, the wavelength sensitivity is the highest, and when Λ is 1.89 μm, the loss is the smallest. Therefore, the distance between adjacent air holes is selected to be 1.89 μm. According to the relationship between thickness and sensitivity shown in the figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance needs to be controlled within the upper and lower limits of 0.5%.

Figure 3F shows the dependence of the loss spectrum on the change in polishing depth D from 2.9 to 3.1 μm for analyte RI of 1.41 and 1.42. According to Figure 3F, the loss gradually decreases as the polishing depth D increases. This is caused by the weak coupling between the core mode and the SPP mode, on the contrary, the loss will gradually increase with the decrease of the polishing depth. This is because the channel between the core and the metal surface is relatively small, and the small channel supports better coupling [37]. And when the polishing depth D is 2.9, 3, and 3.1 μm, the resonance loss peak shift amounts are 126, 167, and 316 nm, respectively. Among them, when D is 3.1 μm, the offset is the largest, but when D is 3.1 μm, the full width at half maximum of the resonance peak does not exist, so the polishing depth D is selected to be 3 μm. The loss spectrum varies greatly when D = 3.1 μm and RI is 1.42, because relatively more light leakage occurs at the core as the distance from

the core to the surface increases. This results in insufficient core mode strength, so that relatively high losses occur in the coupling of the core mode to the plasmon mode of the metal surface [38]. According to the relationship between thickness and sensitivity shown in the figure, in order to obtain a sensor with maximum performance, the manufacturing tolerance needs to be controlled within the upper and lower limits of 3%.

Figure 4A shows the loss curves at different analyte RI (ranging from 1.38 to 1.42). It can be seen from the figure that with the increase of RI, the resonance wavelength is gradually red-shifted, which is because the coupling between the core mode and the SPP mode is continuously enhanced. And the loss first increases and then decreases with the increase of RI, and reaches a peak when RI is 1.4. Figure 4B is the fitted curve of the resonance wavelength as a function of analyte RI. The fitting coefficient R^2 is 0.99936. As can be seen from the figure, when the analyte RI is 1.42, the wavelength sensitivity reaches a maximum of 22,100 nm/RIU.

Conclusion

In order to clearly show the superiority of the designed symmetrically polished D-shaped RI sensor based on Au-TiO$_2$, it is compared with some sensors reported in recent years in terms of performance parameters as shown in Table 1. In this paper, a high-sensitivity D-shape double-sided polished PCF-SPR sensor based on Au-TiO$_2$ is proposed. And based on the finite element method, the RI sensing characteristics are numerically analyzed. The results show a maximum wavelength sensitivity of 22,100 nm/RIU in the refractive index range of 1.38–1.42. Because the designed D-type sensor has a simple structure and adopts an external sensing method, it has potential application prospects in the fields of biology and medicine.

Data availability statement

The original contributions presented in the study are included in the article/supplementary material, further inquiries can be directed to the corresponding author.

Author contributions

QZ: Writing—review and editing. WL: Writing—original draft, supervision, project administration, writing review and editing. QR: Writing—review and editing. JZ: Writing—review and editing. QX: Writing—review and editing. XW: Writing—original draft. All authors have read and agreed to the published version of the manuscript.

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Conflict of interest

The authors declare that the research was conducted in the absence of any commercial or financial relationships that could be construed as a potential conflict of interest.

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